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Docket No. F-7041

**RESPONSE UNDER 37 CFR 1.116**  
**EXPEDITED PROCEDURE**  
**EXAMINING GROUP 2823**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Kiyohiko TAKAGI, et al.  
Serial No. : 09/892,023  
Filed : June 26, 2001  
For : DRYING ETCHING METHOD  
Group Art Unit : 2823  
Examiner : William D. Coleman  
Confirmation No. : 1827  
Customer No. : 000028107

**Certificate of Mailing Under 37 CFR 1.8**

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Lawrence I. Wechsler  
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**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

11/22/2004 AWONDAF1 00000083 101250 09892023

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**INTRODUCTORY COMMENTS:**

Sir:

In response to the final Office Action of July 15, 2004, entry of the present amendment to place the application into condition for allowance or remove issues from appeal, if required, is respectfully requested. Please amend the above-identified patent application as follows: